

<b>Notice of References Cited</b>	Application/Control No. 10/537,275		Applicant(s)/Patent Under Reexamination PORTER ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0030735	02-2003	Ike, Takahiro	348/240.3
*	B	US-2003/0085997	05-2003	Takagi et al.	348/143
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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